

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)
(Large Entity)

Docket No.
 SLA0468

In Re Application Of: Apostolos Voutsas, Yukihi Nakata and Takeshi Hosoda

Serial No.
 09/696,813

Filing Date
 10/25/2000

Examiner
 Khiem D. Nguyen

Group Art Unit
 2823

Invention: A Semiconductor Device and a Method of Creating the Same Utilizing Metal Induced Crystallization While Suppressing Partial Solid Phase Crystallization

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of January 6, 2004 above-identified application.
 Date

The requested extension is as follows (check time period desired):

One month Two months Three months Four months Five months

from: April 6, 2004 _____ until: July 6, 2004
 Date

The fee for the extension of time is \$950 and is to be paid as follows:

A check in the amount of the fee is enclosed.
 The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. 19-1457
 A duplicate copy of this sheet is enclosed.
 If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 19-1457
 A duplicate copy of this sheet is enclosed.

Dated: July 2, 2004

David C. Ripma, Patent Counsel
 Registration No. 27,672
 Sharp Laboratories of America, Inc.
 5750 NW Pacific Rim Boulevard
 Camas, WA 98607
 Ph nre: 360-834-8754
 Facsimile: 360-817-8505

CC:

I certify that this document and fee is being deposited or FAXED with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence
 David C. Ripma, Reg. N. 27,672
 Typed or Printed Name of Person Mailing Correspondence

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